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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/711,899	10/12/2004	Huajie Chen	FIS920040107US1	5898
29154	7590 10/11/2006		EXAMINER	
FREDERICK W. GIBB, III GIBB INTELLECTUAL PROPERTY LAW FIRM, LLC 2568-A RIVA ROAD SUITE 304 ANNAPOLIS, MD 21401			PHAM, LONG	
			ART UNIT	PAPER NUMBER
			2814	
			DATE MAILED: 10/11/2006	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)
	10/711,899	CHEN ET AL.
Office Action Summary	Examiner	Art Unit
	Long Pham	2814
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the	correspondence address
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING D.  - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication.  - If NO penod for reply is specified above, the maximum statutory period of Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATIO 36(a). In no event, however, may a reply be ti will apply and will expire SIX (6) MONTHS from a cause the application to become ABANDONI	N. mely filed  n the mailing date of this communication. ED (35 U.S.C. § 133).
Status		•
<ul> <li>1) Responsive to communication(s) filed on 14 July</li> <li>2a) This action is FINAL.</li> <li>2b) This</li> <li>3) Since this application is in condition for allowed closed in accordance with the practice under Exercise.</li> </ul>	action is non-final.	•
Disposition of Claims		
4)  Claim(s) 8-14 is/are pending in the application 4a) Of the above claim(s) is/are withdray 5)  Claim(s) is/are allowed. 6)  Claim(s) 8-14 is/are rejected. 7)  Claim(s) is/are objected to. 8)  Claim(s) are subject to restriction and/o  Application Papers 9)  The specification is objected to by the Examine	wn from consideration. r election requirement.	
10) The drawing(s) filed on is/are: a) accomplicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Expression of the second	drawing(s) be held in abeyance. Se ion is required if the drawing(s) is ob	e 37 CFR 1.85(a). pjected to. See 37 CFR 1.121(d).
Priority under 35 U.S.C. § 119		•
<ul> <li>12) Acknowledgment is made of a claim for foreign</li> <li>a) All b) Some * c) None of:</li> <li>1. Certified copies of the priority documents</li> <li>2. Certified copies of the priority documents</li> <li>3. Copies of the certified copies of the priority application from the International Bureau</li> <li>* See the attached detailed Office action for a list</li> </ul>	s have been received. s have been received in Applicat rity documents have been receiv u (PCT Rule 17.2(a)).	ion No ed in this National Stage
Attachment(s)		
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal I 6) Other:	ate

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## **DETAILED ACTION**

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In light of the new rejection, the indication of the allowance of claims 8-14 has been withdrawn.

## Claim Rejections - 35 USC § 112

The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

Claims 11 and 12 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

In claim 11, "said epitaxial silicon panel layer" has no antecedent basis.

In claim 11, "said gate conductor" has no antecedent basis.

In claim 12, it is unclear what dopant would constitute halo dopant since specification does not specify it, for examination purpose, any dopant would be considered as halo dopant.

### Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 8-10 are rejected under 35 U.S.C. 102(b) as being anticipated by Hite et al. (US pat 4,863,878).

With respect to claim 8, Hite et al. teach a field effect transistor comprising (see figs. 1A-1D and 2A-2D and associated text):

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A silicon substrate 1, wherein the top surface of said silicon substrate has an increased oxygen content when compared to other portions of said silicon substrate, and wherein said oxygen content of said top surface of said silicon substrate is below an amount that would prevent epitaxial growth (see epitaxial layer 7 or 27) is able to grow thereon;

A silicon halo layer 5 on said top surface of said silicon substrate;

A silicon source/drain layer 7 on said silicon halo layer; and

A gate stack 13 above said silicon source/drain layer.

Further with respect to claim 1, how the silicon halo layer and silicon source/drain layer are formed, that is epitaxial growth, has not been given patentable weight since claim is directed to a device.

With respect to claim 9, Hite et al. further teach the source/drain dopants are substantially limited to the silicon source/drain layer. See figs. 1A-1D and 2A-2D and associated text.

With respect to claim 10, since Hite et al. teach the claimed structure, the increased oxygen content substantially would inherently limit dopants within the silicon layer from moving into said silicon substrate.

## Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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Claims 11-14 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hite et al. (US pat 4,863,878) as applied to claims 8-10 above, and further in view of Noguchi et al. (US pub 2004/0135210).

With respect to claim 12, Hite et al. fail to teach doping the silicon halo layer with a dopant.

However, the doping of a dopant into a silicon layer is well-known.

With respect to claim 14, Hite et al. fail to teach forming spacers on sidewall of the gate.

However, the formation of spacers on sidewall of a gate is well-known in the art.

With respect to claims 11 and 13, Hite et al. fail to teach a column portion or trench having isolation extending from below the gate and through the silicon halo layer and silicon source/drain layers.

Noguchi et al. forming a column portion or trench having isolation 51 extending from below a gate 73 and through a silicon source/drain layer 24 a silicon halo layer 26 to prevent unwanted interaction between devices. See fig. 5 and associated text.

It would have been obvious to one of <u>ordinary skill</u> in the art of making semiconductor devices to incorporate the teaching of Noguchi et al. into the device of Hite et al. to attain the above benefit.

#### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Long Pham whose telephone number is 571-272-1714. The examiner can normally be reached on Mon-Frid, 10am to 5pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael Fahmy can be reached on 571-272-1705. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OP CANADA) or 571-272-1000.

Kong Pham

Primary Examiner

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